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INFORMATION DISCLOSURE STATEMENT BY APPLICANTS PTO FORM 1449	Atty Docket No 10191/1694	Serial No. 09/720938 To Be Assigned
	Applicant(s) Manfred ROTHLEY et al.	
	Filing Date Herewith	Group To Be Assigned

U. S. PATENT DOCUMENTS

EXAMINER'S INITIALS	PATENT NUMBER	PATENT DATE	NAME	CLASS	SUBCLASS	FILING DATE
CH	US 4,695,719* A	Sept 22, 1987	Wilwerding			

*Copy of reference is not enclosed because reference is cited in Search Report (copy of reference provided by International Searching Authority).

FOREIGN PATENT DOCUMENTS

EXAMINER'S INITIALS	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB-CLASS	TRANSLATION	
						YES	NO
CH	EP 0 810 440 A2	Dec. 3, 1997	Europe			X*	
CH	EP 0 809 304 A2	Nov. 26, 1997	Europe			X*	
CH	DE 196 16 969 A1	Oct. 30, 1997	Germany			X*	
CH	DE 296 05 813 U1	June 5, 1996	Germany			X*	
CH	DE 43 01 456 C1	June 23, 1994	Germany			X*	
CH	DE 42 21 037 A1	Jan. 5, 1994	Germany			X*	

*Copy of reference is not enclosed because reference is cited in Search Report (copy of reference provided by International Searching Authority).

OTHER DOCUMENTS

EXAMINER'S INITIALS	AUTHOR, TITLE, DATE, PERTINENT PAGES, ETC.		
	Motamedi et al., "Micro-Opto-Electro-Mechanical Devices and On-Chip Optical Processing", Optical Engineering, U.S. Soc. of Photo-Optical Instrumentation Engineers, Bellingham, Vol. 36, No. 5, pp. 1282-1297*		

*Copy of reference is not enclosed because reference is cited in Search Report (copy of reference provided by International Searching Authority).

EXAMINER	CONSTANTINE HANNAHER	DATE CONSIDERED DEC 16 2002
EXAMINER: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant		